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HKIE Electronics Division Activity Report

Technical Visit to Wong's Kong King Technology Park (WKKT) and Research Institute of Tsinghua University (RITS) in Shenzhen, PRC



Group photo taken in the Wong's Kong King Technology Park

On 15 th May 2004 , a joint technical visit with the Specialised Section in Electronics of the IEE Hong Kong was held. Over 20 members joined the visit to the Wong's Kong King Technology Park (WKKT) and the Research Institute of Tsinghua University (RITS) in Shenzhen, PRC

With the hospitality from Mr. Senta Wong, the Chairman and CEO of the Wong's Kong King International (Holdings) Ltd., we were introduced of various facilities in the WKKT. Workers quarters, recreation area, fire station, staff canteens, electronics assembly lines, and various automatic, advanced and high-tech manufacturing facilities were visited. Mr. Wong and his colleague also gave us an overview on the Quality Assurance Schemes being implemented in the Park.

Having finished our visit in the WKKT, we continued our planned event of visiting the Research Institute of Tsinghua University in Shenzhen. The deputy director of the Administration Office of the Research Institute, Mr. Jing Lu, started the briefing on the history of the RITS. He then introduced the recent developments in the Technology Transfer Centre, including the research and development of the High-Definition Television.

All members gained invaluable experience on the recent development of the technology zones, and we would like to express our gratitude to Mr. Senta Wong and Mr. Lu for their kind arrangement and hospitality during such a wonderful and great event.



Group photo taken at the Research Institute of Tsinghua University in Shenzhen
